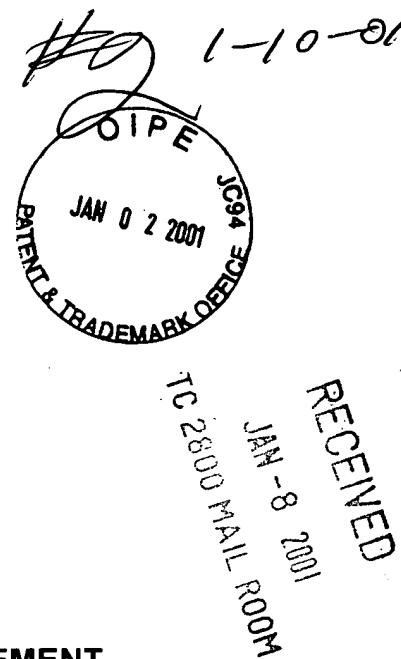


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2 Title: Low Selectivity Deposition Methods
3 Assignee: Micron Technology, Inc.
4 Serial No.: 09/643,004-
5 Filing Date: August 21, 2000



7 **INFORMATION DISCLOSURE STATEMENT**
8 **PURSUANT TO 37 C.F.R. §§1.56, 1.97 AND 1.98**

9 In compliance with 37 C.F.R. §§1.56, 1.97 and 1.98, your attention
10 is directed to the U.S. Patents and other documents listed on the attached
11 Form PTO-1449, and copies of which are attached. No admission is made
12 regarding whether the submitted references are prior art.

13 Citation of these references is respectfully requested.

14 Respectfully submitted,

15
16 Dated: 28 Dec 2000

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